

# CONTENTS

## *Chapter 1*

### **Magnetostrictive Metals and Piezomagnetic Ceramics as Transducer Materials**

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1	Introduction . . . . .	1
1.1.	Ultrasonic Generators and Detectors . . . . .	1
1.2.	Magnetostriction Filters . . . . .	4
2.	Fundamentals of Magnetostriction . . . . .	4
2.1.	Static Magnetostriction Phenomena . . . . .	4
2.2.	Magnetostrictive Forces . . . . .	5
2.3.	Magnetostriction Constants . . . . .	7
2.4.	Material Criteria . . . . .	12
2.5.	Effect of Hydrostatic Pressure on Magnetostriction . . . . .	14
2.6.	Effect of Mechanical Stress on Magnetostriction . . . . .	15
3.	Eddy Current Effects on Material Constants . . . . .	16
4.	Relation between Static and Dynamic Magnetostriction Phenomena . . . . .	19
5.	Methods of Material Measurement . . . . .	20
5.1.	Motional Impedance Methods . . . . .	20
5.2.	Measurement under Hydrostatic Pressure . . . . .	22
5.3.	Measurement under Static Compressive Stress . . . . .	23
6.	Magnetostrictive Properties of Materials . . . . .	24
6.1.	Nickel . . . . .	24
6.2.	Ni-Fe Alloy . . . . .	29
6.3.	Al-Fe Alloy . . . . .	30
6.4.	Other metals . . . . .	34

6.5. Cobalt Rondel . . . . .	37
6.6. Ferrites . . . . .	38
6.7. Theoretical Models for the Characteristics of Magnetostriction in Polycrystalline Metals . . . . .	41
7. Consideration of Large Signal Operation . . . . .	43
7.1. Theoretical Approach . . . . .	43
7.2. Experimental Approach . . . . .	48
References . . . . .	55

## Chapter 2

### Piezoelectric Crystals and Ceramics

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1. Introduction . . . . .	63
2. Fundamentals of Piezoelectricity . . . . .	64
2.1. Basic Action and Linear Static Equations . . . . .	64
2.2. Effect of Crystal Symmetry . . . . .	66
2.3. The Piezoelectric Coupling Factor . . . . .	66
3. Modes of Vibration of Piezoelectric Elements . . . . .	72
3.1. Low-Frequency Modes . . . . .	72
3.2. High-Frequency or Thickness Modes . . . . .	75
3.3. The Effective Coupling Factor—The Piezoelectric Resonator . . . . .	77
4. Ferroelectricity . . . . .	80
4.1. General Description . . . . .	80
4.2. Piezoelectricity in Ferroelectrics—The Piezoelectric Ceramics . . . . .	81
4.3. Nonlinearities—Domain Effects . . . . .	81
4.4. Phase Transitions . . . . .	83
5. Dissipation in Piezoelectric Materials . . . . .	84
5.1. General . . . . .	84
5.2. Effects on Transducer Efficiency and Power Capacity . . . . .	86
6. Parameters of Important Piezoelectric Crystals . . . . .	89
6.1. Older Piezoelectric Crystals . . . . .	89
6.2. Newer Piezoelectric Crystals . . . . .	93
7. Parameters of Piezoelectric Ceramics . . . . .	100
7.1. General . . . . .	100
7.2. Aging in Piezoelectric Ceramics and Effects of High Static Stress . . . . .	110

<b>Contents</b>	<b>ix</b>
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Notation . . . . .	119
References . . . . .	121

*Chapter 3*

**Piezoelectric Transducer Materials and Techniques for Ultrasonic Devices Operating Above 100 MHz**

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1. Introduction . . . . .	125
1.1. Scope of Chapter . . . . .	125
1.2. Results from the Equivalent Circuit Analysis of High-Frequency Ultrasonic Devices Using Piezoelectric Transducers . . . . .	126
1.3. Properties of Transducer Materials and Acoustic Materials of Interest for High-Frequency Applications . . . . .	132
2. Materials and Techniques for Bonded Plate Transducers . . . . .	141
2.1. Single-Crystal Materials . . . . .	141
2.2. Ceramic Transducer Materials . . . . .	154
2.3. Bonding and Lapping Techniques for High-Frequency Transducers . . . . .	158
3. Evaporated and Sputtered Film Transducers . . . . .	163
3.1. Electroelastic Properties of Cadmium Sulfide and Zinc Oxide in the Form of Thin Films . . . . .	163
3.2. Evaporation Techniques for Forming CdS Transducers . . . . .	165
3.3. Sputtering Techniques for Forming ZnO Transducers . . . . .	168
3.4. Other Compounds of Potential Interest for Film Transducers . . . . .	174
4. Concluding Remarks . . . . .	176
References . . . . .	177
<b>Index</b> . . . . .	<b>183</b>